

Information Disclosure Citation in an Application	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
/JJF/	2,278,838	04/07/42	Groote et al.			03/11/40
	2,670,329	02/23/54	Jones			08/03/50
	2,689,244	09/14/54	Jones			06/23/50
	2,819,278	01/07/58	De Groot et al.			05/09/56
	2,877,179	03/10/59	Hughes et al.			03/26/56
	3,008,898	11/14/61	Hughes et al.			06/26/59
	3,052,298	09/04/62	Mallot			03/22/60
	3,065,247	11/10/62	De Groot et al.			11/23/55
	3,326,890	06/20/67	Engelskirchen et al			12/18/64
	3,336,980	08/22/67	Rike			02/09/67
	3,489,222	01/13/70	Millhone et al.			12/26/68
	3,601,194	08/24/71	Gallus			07/14/69
	3,647,507	03/07/72	Ashcraft			01/07/70
	3,689,418	09/05/72	Cenci et al.			12/14/70
	3,708,013	01/02/73	Dismukes			05/03/71
	3,709,298	01/09/73	Pramann			05/20/71
	3,902,557	09/02/75	Shaughnessy, et al.			03/25/74
	3,943,060	03/09/76	Martin, et al.			07/26/74
	3,983,941	10/05/76	Fitch			11/10/75
	4,052,345	10/04/77	Austin, et al.			06/25/75
	4,228,277	10/14/80	Landoll			02/12/79
	4,441,556	04/10/84	Powers, et al.			08/17/81
	4,499,214	02/12/85	Sortwell			05/03/83
	4,619,776	10/28/86	Mondshine			08/09/85
	4,662,448	05/05/87	Ashford, et al.			04/25/86
	4,702,319	10/27/87	Bock, et al.			12/29/86
	4,828,725	05/09/89	Lai et al.			03/04/88
	4,856,590	08/15/89	Caillier			11/28/86
	4,870,167	09/26/89	Zody, et al.			03/02/87
	4,941,537	07/17/90	Langemeier, et al.			06/22/89
	4,960,876	10/02/90	Molteni, et al.			12/22/88
	5,051,197	09/24/91	Kalfayan, et al.			10/10/90
	5,105,886	04/21/92	Strubhar, et al.			10/24/90
✓	5,256,651	10/26/93	Phelps, et al.			05/27/92
	5,424,284	06/13/95	Patel et al.			07/02/93
/JJF/	5,445,223	08/29/95	Nelson, et al.			03/15/94

EXAMINER /John J. Figueroa/	DATE CONSIDERED 03/16/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

Information Disclosure Citation in an Application	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
/JJF/	5,597,783	01/28/97	Audibert, et al			05/04/95
	5,637,556	06/10/97	Argillier, et al			05/04/95
	5,643,460	07/01/97	Marble, et al.			06/30/95
	5,681,796	10/28/97	Nimerick			07/29/94
	5,704,426	01/06/98	Rytlewski, et al.			03/20/96
	5,720,347	02/24/98	Audibert, et al			01/11/96
	5,908,814	06/01/99	Patel, et al.			07/03/95
	5,990,052	11/23/99	Harris			07/25/96
	6,209,646	04/03/01	Reddy, et al			04/21/99
	6,242,390	06/05/01	Mitchell, et al.			07/31/98
	6,281,172	08/28/01	Warren, et al.			04/07/99
	6,291,404	09/18/01	House			02/13/01
	6,562,762	05/13/03	Cowan, et al.			07/03/01
	6,601,648	08/05/03	Ebinger			10/22/01
	6,607,035	08/19/03	Reddy, et al.			10/26/00
	6,626,241	09/30/03	Nguyen			12/06/01
	6,637,517	10/28/03	Qu, et al			01/17/02
	6,656,885	12/02/03	House, et al			01/03/02
	6,743,288	06/01/04	Eoff, et al.			10/28/02
	6,764,981	07/20/04	Eoff, et al			03/21/03
	6,767,867	07/27/04	Chatterji, et al.			04/15/02
	6,767,869	07/27/04	DiLullo, et al			04/09/02
	6,780,822	08/24/04	Cowan, et al			01/21/03
	6,846,420	01/25/05	Reddy, et al			12/19/02
	6,884,760	04/26/05	Brand, et al			05/20/02
	6,962,203	11/08/05	Funchess			03/24/03
	6,978,836	12/27/05	Nguyen, et al			05/23/03
	6,981,552	01/03/06	Reddy, et al			03/21/03
	7,007,752	03/07/06	Reddy, et al			12/04/03
	7,008,908	03/07/06	Chan, et al			11/22/02
	7,036,587	05/02/06	Munoz, Jr., et al			06/27/03
	7,036,589	05/02/06	Nguyen			08/14/03
↓	7,091,159	08/15/06	Eoff, et al.			09/06/02
	7,182,136	02/27/07	Dalrymple, et al			07/02/03
/JJF/	7,220,708	05/22/07	Zamora, et al			02/27/03

EXAMINER /John J. Figueroa/	DATE CONSIDERED 03/16/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.	

Information Disclosure Citation in an Application	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

U.S. PATENT DOCUMENTS

	DOCUMENT NO.	ISSUE/PUB. DATE	NAME	CLASS	SUBCLASS	FILING DATE
--	--------------	-----------------	------	-------	----------	-------------

NON-PATENT DOCUMENTS

	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)					
/JJF/	Office action dated 12/28/2007 from application serial number 10/806,894					12/28/2007
	Office action dated 7/12/2007 from application serial number 10/806,894					7/12/2007
	Office action dated 4/9/2007 from application serial number 10/806,894					4/9/2007
	Office action dated 1/3/2007 from application serial number 10/806,894					1/3/2007
	Office action dated 7/3/2006 from application serial number 10/806,894					7/3/2006
	Notice of allowance dated 1/28/2008 from application serial number 11/102,062					1/28/2008
	Office action dated 6/27/2007 from application serial number 11/102,062					6/27/2007
	Office action dated 5/1/2007 from application serial number 11/122,836					5/1/2007
	Office action dated 11/14/2007 from application serial number 11/122,836					11/14/2007
	Office action dated 2/1/2008 from application serial number 10/440,337					2/1/2008
	Office action dated 11/15/2006 from application serial number 10/440,337					11/15/2006
	Office action dated 5/3/2006 from application serial number 10/440,337					5/3/2006
	Notice of allowance dated 3/23/2006 from application serial number 10/236,722					3/23/2006
	Office action dated 9/28/2005 from application serial number 10/236,722					9/28/2005
	Office action dated 7/5/2005 from application serial number 10/236,722					7/5/2005
	Office action dated 4/19/2005 from application serial number 10/236,722					4/19/2005
	Office action dated 10/20/2004 from application serial number 10/236,722					10/20/2004
	Notice of allowance dated 3/23/2006 from application serial number 10/612,271					3/23/2006
	Notice of allowance dated 7/18/2006 from application serial number 10/825,001					7/18/2006
	Office action dated 1/6/2006 from application serial number 10/825,001					1/6/2006
	Notice of allowance dated 8/17/2006 from application serial number 10/881,198					8/17/2006
	Notice of allowance dated 5/25/2006 from application serial number 10/881,198					5/25/2006
	Notice of allowance dated 3/5/2007 from application serial number 10/893,210					3/5/2007
	Notice of allowance dated 2/27/2007 from application serial number 10/893,210					2/27/2007
	Office action dated 9/12/2006 from application serial number 10/893,210					9/12/2006
/JJF/	Office action dated 1/14/2008 from application serial number 11/471,148					1/14/2008

EXAMINER	/John J. Figueroa/	DATE CONSIDERED 03/16/2008
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.		

Information Disclosure Citation in an Application	Application No. 10/760,443	Applicant(s) Eoff et al.	
	Docket Number HES 2001-IP-005267U1P1	Group Art Unit 1712	Filing Date January 20, 2004

NON-PATENT DOCUMENTS

		DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	
	/JJF/	Office action dated 11/2/2007 from application serial number 11/471,148	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,148	9/20/2007
		Office action dated 4/5/2007 from application serial number 11/471,148	4/5/2007
		Office action dated 1/14/2008 from application serial number 11/471,738	1/14/2008
		Office action dated 11/2/2007 from application serial number 11/471,738	11/2/2007
		Office action dated 9/20/2007 from application serial number 11/471,738	9/20/2007
		Office action dated 4/6/2007 from application serial number 11/471,738	4/6/2007
		Office action dated 9/24/2007 from application serial number 10/862,132	9/24/2007
		Office action dated 7/12/2007 from application serial number 10/862,132	7/12/2007
	↓	Office action dated 1/22/2007 from application serial number 10/862,132	1/22/2007
	/JJF/	Office action dated 7/28/2006 from application serial number 10/862,132	7/28/2006
	/JJF/	Proett, et al., <i>Advanced Dual Probe Formation Tester with Transient, Harmonic, and Pulsed Time-Delay Testing Methods Determines Permeability, Skin, and Anisotropy</i> , SPE 64650, 2000, Society of Petroleum Engineers Inc., presented at the SPE International Oil and Gas Conference and Exhibition in China held in Beijing, China, November 7-10, 2000	11/7/00
	/JJF/	Proett, et al., <i>Advanced Permeability and Anisotropy Measurements While Testing and Sampling in Real-time Using a Dual Probe Formation Tester</i> , SPE 62919, 2000, Society of Petroleum Engineers Inc., presented at the 2000 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 1-4, 2000	10/1/00
	/JJF/	Bai, et al., <i>Improved Determination of Stress-Dependent Permeability for Anisotropic Formations</i> , SPE/ISRM 78188, 2000, Society of Petroleum Engineers Inc., presented at the SPE/ISRM Rock Mechanics Conference held in Irving, Texas, October 20-23, 2002	10/20/02
	/JJF/	Parker, et al., <i>Laser Drilling: Effects of Beam Application Methods on Improving Rock Removal</i> , SPE 84353, 2003, Society of Petroleum Engineers Inc., presented at the SPE Annual Technical Conference and Exhibition held in Denver, Colorado, October 5-8, 2003	10/5/03
	/JJF/	Xu, et al., <i>Modeling of Laser Spallation Drilling of Rocks for Gas-and Oilwell Drilling</i> , SPE 95746, 2005, Society of Petroleum Engineers Inc., presented at the 2005 SPE Annual Technical Conference and Exhibition held in Dallas, Texas, October 9-12, 2005	10/9/03
	/JJF/	Batarese, et al., <i>Well Perforation Using High-Power Lasers</i> , SPE 84418, 2003, Society of Petroleum Engineers Inc., presented at the SPE Annual Technical Conference and Exhibition held in Denver, Colorado, October 5-8, 2003	10/5/03

EXAMINER /John J. Figueroa/

DATE CONSIDERED
03/16/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.